

Notice of References Cited	Application/Control No. 09/450,609	Applicant(s)/Patent Under Reexamination WEIBEL ET AL.	
	Examiner Jennifer Kim	Art Unit 1617	Page 1 of 1

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*	B	US-4,280,997	07-1981	Van Leverink, Johannes	424/676
*	C	US-6,710,050	03-2004	Weibel et al.	514/266.2
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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